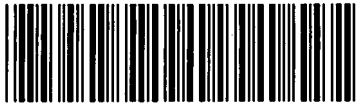


<b>Search Notes</b>  	<b>Application/Control No.</b>  10796864	<b>Applicant(s)/Patent Under Reexamination</b>  LIANG, CHENG-CHUNG
	<b>Examiner</b>  Radkiewicz, Jared W	<b>Art Unit</b>  2609

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
382	173	5/31/2007	JWR

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Keyword limit searched 382/154 and 183/173	5/31/2007	JWR

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
382	173	5/31/2007	JWR